

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Katsumi MIYATA, et al.**

Serial Number: **NEW**

Filed: **January 5, 2000**

For: **SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME**

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

January 6, 2000

Sir:

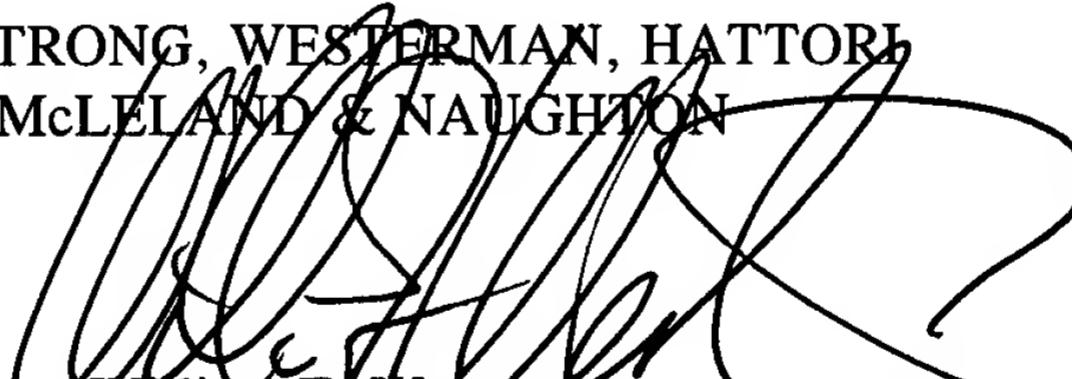
In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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